

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **CORNELIS PETRUS ANDREAS MARIE LUIJKX**
 VADIM YEVGENYEVICH BANINE
 HAKO BOTMA
 MARTINUS VAN DUIJNHOFEN
 MARKUS FRANCISCUS ANTONIUS EURLINGS
 HEINE MELLE MULDER
 HANS MUIJDERMAN
 CORNELIS JACOBUS VAN DUIJN

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|------------------|---|---------------------|
| Application No.: | TO BE ASSIGNED | Confirmation No: |
| Filed: | December 31, 2003 | Group No.: |
| | | Examiner |
| For: | OPTICAL ATTENUATOR DEVICE, RADIATION SYSTEM AND LITHOGRAPHIC APPARATUS THEREWITH AND DEVICE MANUFACTURING METHOD | |

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: **CORNELIS PETRUS ANDREAS MARIE LUIJKX**
Citizenship: The Netherlands
Residence: Frans Halsstraat 30, NL-5684 AH Best, The Netherlands

Second applicant: **VADIM YEVGENYEVICH BANINE**
Citizenship: The Netherlands
Residence: Nierslaan 2, NL-5704 NK Helmond, The Netherlands

Third applicant: **HAKO BOTMA**
Citizenship: The Netherlands
Residence: Evertsenstraat 9, NL-5612 KP Eindhoven, The Netherlands

Fourth applicant: **MARTINUS VAN DUIJNHOFEN**
Citizenship: The Netherlands
Residence: Warande 8, NL-5752 AE Deurne, The Netherlands

Fifth applicant: **MARKUS FRANCISCUS ANTONIUS EURLINGS**
Citizenship: The Netherlands
Residence: Oosterbeekstraat 31, NL-5045 TH Tilburg, The Netherlands

Sixth applicant: **HEINE MELLE MULDER**
Citizenship: The Netherlands/United States of America
Residence: Kruisakker 60, NL-5625 SE Eindhoven, The Netherlands

Seventh applicant: **HANS MUIJDERMAN**
Citizenship: The Netherlands
Residence: Veldhoven, The Netherlands

Eighth applicant: **CORNELIS JACOBUS VAN DUIJN**
Citizenship: The Netherlands
Residence: Klaver 2, NL-5684 HZ Best, The Netherlands

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: OPTICAL ATTENUATOR DEVICE, RADIATION SYSTEM
AND LITHOGRAPHIC APPARATUS THEREWITH AND
DEVICE MANUFACTURING METHOD

Docket number assigned to this application: 081468-0307475

Total number of drawing sheets: 14

Type of application: Utility

Application is to be published. Suggested drawing figure for publication: FIGURE 2

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

The assignee(s) of this application is/are:

ASML NETHERLANDS B.V.

De Run 1110, NL-5503 LA Veldhoven, THE NETHERLANDS

Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST

Date: **December 31, 2003**

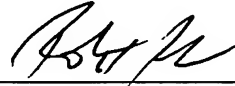
PILLSBURY WINTHROP LLP

P.O. Box 10500

McLean, VA 22102

Tel. No.: (703) 905-2159

Customer No.: 00909



Signature of Practitioner

Robert C. Perez

Reg. No.: 39328